

Title (en)

Inductive microsensor flatly formed on a substrate

Title (de)

Induktiver Mikrosensor, flach hergestellt auf einem Substrat

Title (fr)

Micro-capteur inductif formé à plat sur un substrat

Publication

EP 1308969 B1 20090415 (FR)

Application

EP 01204214 A 20011106

Priority

EP 01204214 A 20011106

Abstract (en)

[origin: EP1308969A1] A flat microcoil (2) formed on an integrated circuit (4), comprises long conductive segments (Si) with high aspect ratio, each segment arranged in perpendicular direction with respect to the adjacent long segment (Si+1). Each long segment is connected with the adjacent segment by a short segment, so as to form angles of 135 degrees with the long segments.

IPC 8 full level

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CPC (source: EP US)

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